

Form PTO-1449

Attorney Docket No.
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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

MAY 14 2004

Applicant
Yonhua TzengFiling Date
February 5, 2004Group
1762

U.S. PATENT DOCUMENTS

Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
EF	A	6,284,315	9/4/01	Tzeng	427	249.1	1/14/00

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation
						Yes No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EF	B	Tzeng, et al.; Effects of oxygen and hydrogen on electron field emission from microwave plasma chemically vapor deposited microcrystalline diamond, nanocrystalline diamond, and glassy carbon coatings

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

EXAMINER'S SIGNATURE:

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DATE CONSIDERED:

06/25/2006